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THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Katsuhide MANABE et al.

Serial No.: 10/052,347

Group Art Unit: 2812

Filed: January 23, 2002

Examiner: Mulpuri, S.

For: A METHOD FOR MANUFACTURING A GALLIUM NITRIDE GROUP  
COMPOUND SEMICONDUCTOR

Honorable Commissioner of Patents  
Alexandria, VA 22313-1450

**RESPONSE**

Sir:

In response to the Office Action dated June 21, 2004, Applicant states as follows: